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CONFIRMATION NO. 9181

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/521,248	04/11/2005	438	2895	122430		
RULE						
APPLICANTS Hideharu Itatani, Tokyo, JAPAN; Sadayoshi Horii, Tokyo, JAPAN; Masayuki Asai, Tokyo, JAPAN; Atsushi Sano, Tokyo, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08964 07/15/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-205627 07/15/2002 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/13/2005						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /CARIDAD EVERHART/ Acknowledged Examiner's Signature		Initials	JAPAN	6	20	3
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
TITLE Method for manufacturing semiconductor device and substrate processing apparatus						
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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